

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Daping CHU

Application No.: New U.S. Patent Application

Filed: June 7, 2005

Docket No.: 124144

For: SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The references 4-8 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 3. The references 1-3, 5, 7 and 9-12 were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 5. English language Abstracts of the non-English language references 5-6 and 9-10 are attached hereto.


10/537809

JC17 Rec'd PCT/PTO 07 JUN 2005

☒ 6. A computer-generated English language translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office (<http://www.jpo.go.jp>), and is attached, but has not been reviewed for accuracy. See Reference 9.

☒ 7. A partial translation of reference 5 is attached.

Respectfully submitted,


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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 124144		APPLICATION NO. New U.S. National Stage of PCT/GB2004/002972 107537809	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Daping CHU			
				FILING DATE June 7, 2005		2826	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
/MLT/	1	5,808,344	09/15/1998	Ismail et al.			
/MLT/	2	3,840,888	10/08/1974	Gaensslen et al.			
/MLT/	3	US 2002/0142571 A1	10/03/2002	Noguchi			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
/MLT/	4	JP 53-149770	12/27/1978	Japan			
/MLT/	5	JP A 56-021371 A abstract and partial translation	02/27/1981	Japan			
/MLT/	6	JP A 60-63948 w/abstract	04/12/1985	Japan			
/MLT/	7	GB 1 448 303	09/02/1976	Great Britain			
/MLT/	8	GB 2 363 905 A	01/09/2002	Great Britain			
/MLT/	9	JP A 11-266019 w/abstr. + trans.	09/28/1999	Japan			
/MLT/	10	JP A 60/234353 w/abstract	11/21/1985	Japan			
/MLT/	11	WO 00/60665	10/12/2000	WIPO			
/MLT/	12	EP 0 785 578 A2	07/23/1997	Europe			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER /Minh-Loan Tran/					DATE CONSIDERED 06/23/2008		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /MLT/

Date: June 7, 2005